



Docket No.: Z&PINFN10309

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant : Matthias Goldbach, et al.  
Applic. No. : 10/616,396  
Filed : July 9, 2003  
Title : Method for Fabricating Trench Capacitors for Integrated Semiconductor Memories

**ASSOCIATE POWER OF ATTORNEY**

Commissioner for Patents,  
P.O. Box 1450, Alexandria, VA 22313-1450

Sir:

Please recognize MARKUS NOLFF (Reg. No. 37,006) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

Lerner and Greenberg, P.A.  
P.O. Box 2480  
Hollywood, Florida 33022-2480

Respectfully submitted,

For Applicant

WERNER H. STEMER  
REG. NO. 34,956

Date: August 20, 2003

Lerner and Greenberg, P.A.  
Post Office Box 2480  
Hollywood, FL 33022-2480  
Tel: (954) 925-1100  
Fax: (954) 925-1101

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